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Docket No.: 2328-050A

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of	:	EXPEDITED PROCEDURE
	:	Response under 37 CFR 1.116
Jian J. CHEN et al.	:	Confirmation No. 3505
	:	
U.S. Patent Application No. 10/647,347	:	Group Art Unit: 1763
	:	
Filed: August 26, 2003	:	Examiner: LUZ L ALEJANDRO
For: INDUCTIVE PLASMA PROCESSOR METHOD		

AMENDMENT UNDER RULE 116

Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

May 9, 2005

Sir:

This paper is submitted in reply to the Office Action mailed March 9, 2005, which was made Final. Applicants respectfully request that the following amendments as to form be entered to place this application in condition for allowance.